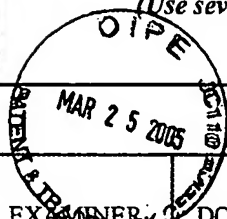


U.S. Department of Commerce  <b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b> <i>(Use several sheets if necessary)</i>	<b>ATTY. DOCKET NO.</b> DKC 1720.01	<b>SERIAL NO.:</b> 10 731 757
	<b>APPLICANT:</b> YANG ET AL	
	<b>FILING DATE:</b> DECEMBER 8 2003	<b>GROUP:</b> 1712



## U.S. PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
DR	4 883 835	11/28/89	Buysch et al.	524	504	
	4 983 658	1/8/91	Kress et al.	524	141	
	✓ 6 437 029	8/20/02	Lim et al.	524	97	
	✓ 6 576 161	6/10/03	Lim et al.	252	609	
	6 630 524	10/7/03	Lim et al.	524	100	
↓	6 797 754	9/28/04	Yang et al.			
	<del>10 480 180</del>	<del>12/8/03</del>	<del>Yang et al.</del>			
	<del>10 480 056</del>	<del>12/8/03</del>	<del>Yang et al.</del>			

no  
such  
pat.  
no.

## FOREIGN PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
DR	✓ 1994-0014647	7/19/94	Korea				X
	✓ 8-208884	8/13/96	Japan				X
	✓ 7-76649	3/2/95	Japan				X
↓	✓ EP 0 728 811 A2	8/28/96	Europe			X	

EXAMINER INITIALS	<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>	
DR	✓ Abstract of Korean Patent Application Laid-open No. 94-14647, July 19, 1994 ✓ Abstract of Japanese Patent Laid-open No. 8-208884, August 13, 1996 ✓ Abstract of Japanese Patent Laid-open No. 7-76649, March 2, 1995 ✓ Abstract of EP0936244, August 18, 1999	
EXAMINER	DATE CONSIDERED	
David Butcher	5/16/05	
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